IN THE UNITED SPACES PATENT AND TRADEMARK OFFICE

OCT 1 0 2006

Applicant(s): HIMI et al.

Serial No.: 10/716,606

Filed: November 20, 2003

Title: METHOD FOR MANUFACTURING

SEMICONDUCTOR SUBSTRATE

Commissioner for Patents Alexandria, VA 22313-1450 Atty. Dkt.: 01-100-DIV

Group Art Unit: 2813

Examiner: PHAM, THANHHA S.

Date: October 10, 2006

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to 37 C.F.R. §1.56, the reference(s) listed on the attached Form PTO-1449 is/are being brought to the attention of the Examiner without any admission that it/they constitute(s) statutory prior art, or without any admission that it/they contain(s) subject matter that anticipates the invention or renders the invention obvious to a person of ordinary skill in the art.

Further, pursuant to 37 C.F.R. §1.97(e), the undersigned hereby certifies no item of information contained in the information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application more than three months prior to the filing of the information disclosure statement.

As a Final Office Action was mailed on June 2, 2006, a check for \$180 is enclosed to cover the requisite Information Disclosure Statement fee required by 37 C.F.R. §1.97 (d) (2). It is respectfully requested that any additional fees be charged to Deposit Account 50-1147.

Also, the Examiner is requested to initial the attached PTO Form-1449 and to return a copy of same to the undersigned attorney as proof that the listed reference(s) has/have been considered and made of record.

Respectfully submitted,

David G. Posz

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* PATENT APPLICATION

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U.S. PATENT DOCUMENTS

EXAMINER INITIAL	 DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS

FOREIGN PATENT DOCUMENTS

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		DOCUMENT NUMBER	DATE	COUNTRY	NAME	CLASS	SUB	YES	NO	
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^{*} Full English text is available in machine-translated form in JPO (Japanese Patent Office) English language web site at http://www1.ipdl.jpo.go.jp/PA1/cgi-bin/PA1INDEX.

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)

	Examination Report from European Patent Office issued on September 14, 2006 for the corresponding European patent application No. 00 125 154.5-1528 (a copy and English translation thereof)
EXAMINER	DATE CONSIDERED

Rev. 10/94 (Form 3.05)